

BILLING CODE 3510-DS-P

DEPARTMENT OF COMMERCE

International Trade Administration

Dana-Farber Cancer Institute, et al.

Notice of Consolidated Decision on Applications

for Duty-Free Entry of Electron Microscope

This is a decision consolidated pursuant to Section 6(c) of the Educational, Scientific, and Cultural Materials

Importation Act of 1966 (Pub. L. 89-651, as amended by Pub. L. 106-36; 80 Stat. 897; 15 CFR part 301). Related records can be viewed between 8:30 A.M. and 5:00 P.M. in Room 3720, U.S. Department of Commerce, 14th and Constitution Avenue, NW, Washington, D.C.

Docket Number: 15-047. Applicant: Dana-Farber Cancer Institute, Boston, MA 02210. Instrument: Electron Microscope. Manufacturer: JEOL Ltd., Japan. Intended Use: See notice at 81 FR 11517, March 4, 2016.

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Docket Number: 15-051. Applicant: Iowa State University of Science and Technology, Ames, IA 50011-3020.

Instrument: Electron Microscope. Manufacturer: FEI

Company, Czech Republic and Great Britain. Intended Use:

See notice at 81 FR 32724, May 24, 2016.

Docket Number: 15-054. Applicant: University of

Connecticut Health Center, Farmington, CT 06030.

Instrument: Electron Microscope. Manufacturer: FEI

Company, Czech Republic. Intended Use: See notice at 81

FR 11517, March 4, 2016.

Docket Number: 15-056. Applicant: St. Jude Children's
Research Hospital, Memphis, TN 38105. Instrument:
Electron Microscope. Manufacturer: FEI Company, Czech
Republic. Intended Use: See notice at 81 FR 11517, March
4, 2016.

Docket Number: 15-059. Applicant: Rutgers University,
Piscataway, NJ 00854. Instrument: Low Temperature
Scanning Tunneling Microscope. Manufacturer: Unisoku,
Japan. Intended Use: See notice at 81 FR 11517, March 4,
2016.

Docket Number: 15-060. Applicant: Kent State University,
Kent, OH 44242. Instrument: Electron Microscope.

Manufacturer: FEI Company, the Netherlands. Intended Use:
See notice at 81 FR 11517, March 4, 2016.

Docket Number: 16-003. Applicant: Oregon Health and Science University, Portland, OR 97239. Instrument: Electron Microscope. Manufacturer: FEI Company, the Netherlands. Intended Use: See notice at 81 FR 32724-25, May 24, 2016.

Docket Number: 16-006. Applicant: Texas Southwestern

Medical Center, Dallas, TX 75390. Instrument: Electron

Microscope. Manufacturer: FEI Company, the Netherlands.

Intended Use: See notice at 81 FR 32724-25, May 24, 2016.

Docket Number: 16-009. Applicant: Stanford University, Stanford, CA 94305-5126. Instrument: Electron Microscope. Manufacturer: FEI Company, the Netherlands. Intended Use: See notice at 81 FR 32724, May 24, 2016.

Comments: None received. Decision: Approved. No

instrument of equivalent scientific value to the foreign instrument, for such purposes as this instrument is intended to be used, is being manufactured in the United States at the time the instrument was ordered. Reasons:

Each foreign instrument is an electron microscope and is intended for research or scientific educational uses requiring an electron microscope. We know of no electron microscope, or any other instrument suited to these purposes, which was being manufactured in the United States at the time of order of each instrument.

Gregory W. Campbell Director Subsidies Enforcement Office Enforcement and Compliance

July 22, 2016 Date

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